

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 5686**
Mitsuo SAITOH et al. : Attorney Docket No. 2003_1228A
Serial No. 10/649,670 : Group Art Unit 1792
Filed August 28, 2003 : Examiner Allan W. Olsen
PLASMA PROCESSING METHOD AND
APPARATUS **Mail Stop: AF**

AMENDMENT UNDER 37 CFR 1.116(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of June 25, 2008, please amend the above-referenced U.S.
patent application as follows: